L Number	Hits	Search Text	DB	Time stamp
37	4967	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4	USPAT;	2004/10/16 15:41
		etch\$3) with (dielectric insulat\$3)) and (cathode electrode)	US-PGPUB	
38	2454	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4	USPAT;	2004/10/16 15:41
		etch\$3) with (dielectric insulat\$3)) same (cathode electrode)	US-PGPUB	
51	25	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4	USPAT;	2004/10/16 15:46
		etch\$3) with (dielectric insulat\$3)) same (cathode electrode)) and	US-PGPUB	
		156/\$.ccls.		
52	1081	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4	EPO; JPO;	2004/10/16 15:46
		etch\$3) with (dielectric insulat\$3)) same (cathode electrode))	DERWENT	200 1, 20, 20 201 10
53	15	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4	EPO; JPO;	2004/10/16 15:50
		etch\$3) with (thick near3 (dielectric insulat\$3))) same (cathode	DERWENT	200 1/10/10 15.50
		electrode))	DERVICIAL	
54	1	5047313.pn.	USPAT;	2004/10/16 15:54
·	•	35 17 313.pm.	US-PGPUB	2007/10/10 13.37
55	0	(multil\$layer\$3 near3 cathode) and (dielectric insulat\$3)		2004/10/16 15:55
33	U	(mulciplayer \$3 freat 3 cautode) and (dielectric insulat\$3)	USPAT;	2004/10/16 15:55
56	901	(multitle yout?) with eatheds) and (disloctive insulate?)	US-PGPUB	2004/40/46 45 55
30	801	(multi\$layer\$3 with cathode) and (dielectric insulat\$3)	USPAT;	2004/10/16 15:55
	202		US-PGPUB	
57	203	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3)	USPAT;	2004/10/16 15:55
			US-PGPUB	
58	67	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3) and	USPAT;	2004/10/16 15:59
	_	(313/\$.ccls.)	US-PGPUB	
59	7	(multi\$layer\$3 near3 cathode) and (thick near3 (dielectric	USPAT;	2004/10/16 16:00
		insulat\$3 isolat\$3)) and (313/\$.ccls.)	US-PGPUB	
60	333	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) and	USPAT;	2004/10/16 16:40
		(cathode electrode) and (((electron field) near3 (emitting emission	US-PGPUB	
		emissive emitter))) and (313/\$.ccls.)		
61	82	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same	USPAT;	2004/10/16 17:11
		pattern\$3) and (cathode electrode) and (((electron field) near3	US-PGPUB	
		(emitting emission emissive emitter))) and (313/\$.ccls.)		
62	22	("3731131" "3998678" "4193013" "4345181" "4498952"	USPAT	2004/10/16 16:45
		"4551649" "4683399" "5019003" "5129850" "5138220"		-00 1, 20, 20 201 10
j		"5141460" "5180951" "5190796" "5199918" "5202571"		
		"5227699" "5249340" "5252833" "5278475" "5371431"		
ì		"5449970" "5451830").PN.		
63	4	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same	EPO; JPO;	2004/10/16 17:08
		pattern\$3) and (cathode electrode) and (((electron field) near3	DERWENT	200 1/10/10 17:00
		(emitting emission emissive emitter)))	DERWEIT	
64	46	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric)) and	EPO; JPO;	2004/10/16 17:08
İ		(cathode electrode) and (((electron field) near3 (emitting emission	DERWENT	2001/10/10 17:00
		emissive emitter)))	DERWEIT	
65	3	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same	USPAT;	2004/10/16 17:13
		pattern\$3) and (cathode electrode) and (((electron field) near3	US-PGPUB	2004/10/16 17:13
		(emitting emission emissive emitter))) and (216/\$.ccls.)	03-49-09	
66	62	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) with	LICDATA	2004/10/16 17:21
	02	pattern\$3) and (cathode electrode) and (((electron field) near3	USPAT; US-PGPUB	2004/10/16 17:21
]		(emitting emission emissive emitter)))	US-PGPUB	
67	4	(emitting emission emissive emitter)))	LICDAT	2004/40/45 47 15
68	3584	("3970887" "4513308" "5266530" "5358908").PN.	USPAT	2004/10/16 17:13
UO	338 4	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode	USPAT;	2004/10/16 17:22
		electrode) and (((electron field) near3 (emitting emission emissive	US-PGPUB	
60	00	emitter)))		
69	88	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode	USPAT;	2004/10/16 19:24
		electrode) and (((electron field) near3 (emitting emission emissive	US-PGPUB	
70		emitter))) and (216/\$.ccls.)		
70	19	((dielectric insulat\$3 isolat\$3) with thick with pattern\$3) and	USPAT;	2004/10/16 19:25
		(216/13,17,62,87,95.ccls.)	US-PGPUB	
71	19	((dielectric insulat\$3 isolat\$3) with thick) and (216/62.ccls.)	USPAT;	2004/10/16 19:26
		·	US-PGPUB	
72	151	((dielectric insulat\$3 isolat\$3)) and (216/62.ccls.)	USPAT;	2004/10/16 19:26
ļ			US-PGPUB	
73	91	((dielectric insulat\$3 isolat\$3)) and (cathode electrode conductor)	USPAT;	2004/10/16 19:33
		and (216/62.ccls.)	US-PGPUB	=,, 20 23.33

-	1371	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 11:18
-	5	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:19
-	20	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and 430/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:21
-	31	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and 216/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:24
-	49	(((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and 430/\$.ccls.) (((diffus\$3 near3	USPAT;	2004/07/20 11:21
		(pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and 216/\$.ccls.)	US-PGPUB	
-	113	((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric))	USPAT;	2004/07/20 11:24
-	198	and (cathode electrode) and 216/\$.ccls. ((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric))	US-PGPUB USPAT;	2004/07/20 11:24
-	128	and (cathode electrode) and (216/\$.ccls. 430/\$.ccls. 445/\$.ccls.) (diffus\$3 with (pattern\$3 etch\$3) with (insulat\$3 dielectric)) and	US-PGPUB USPAT;	2004/07/20 11:50
-	42	(cathode electrode) and (216/\$.ccls. 430/\$.ccls. 445/\$.ccls.) (actinic near3 (radiat\$3)) and 445/\$.ccls.	US-PGPUB USPAT;	2004/07/20 11:51
-	42	(actinic near3 (radiat\$3)) and 445/\$.ccls.	US-PGPUB USPAT; US-PGPUB	2004/07/20 11:51
_	2	(actinic near3 (radiat\$3)) and 445/\$.ccls.	USOCR	2004/07/20 11:51
-	13	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 13:35
-	112	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 13:36
-	140	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 13:37
_	66	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls 445/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 13:38
-	16	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls 445/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 16:01
-	10	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (313/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 15:53
-	20	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (cathode electrode) and ((field electron) near3 (emitter source emission emitting emissive))	USPAT; US-PGPUB	2004/07/20 16:12
-	2	(actinic same (radiat\$3 irradiat\$3 expos\$3 develop\$4) same (dielectric insulat\$3)) and (cathode electrode) and ((field electron)	EPO; JPO; DERWENT	2004/07/20 16:12
_	1	near3 (emitter source emission emitting emissive)) 1998-532288.NRAN.	DEDIMENT	2004/07/20 46:42
-	249	((diffusion with pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting))	DERWENT USPAT; US-PGPUB	2004/07/20 16:12 2004/07/22 15:44
-	699	((diffusion same pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting))	USPAT; US-PGPUB	2004/07/22 15:44
-	0	(diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive	USPAT; US-PGPUB	2004/07/22 15:47
-	2	emitting) near3 (display device panel)) (diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive	USPAT; US-PGPUB	2004/07/22 15:47
-	62	emitting)) ((difus\$3patern\$3 (diffus\$3 near3 pattern\$3)) same (insualat\$3	USPAT;	2004/10/08 14:03
	700	dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB	
-	702	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emission emission emission)	USPAT; US-PGPUB	2004/10/08 14:03
L	L	emitting emission emissive emitter)))	L	<u> </u>

dielectric isolats3) and (((electron field) near3 (source emitting emission emissive emitter))					
emission emissive emitteri)) and (445/\$.ccls. 313/\$.ccls. 313/\$.	-	23	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3		2004/10/08 14:20
430/s.cds.) 1 5032216.pn. 1 50322216.pn. 1 50322216.			dielectric isolat\$3)) and (((electron field) near3 (source emitting	US-PGPUB	
1 5032216 pm. 15032216 pm. 1503231 pm. 15032216 pm. 150322216 pm. 15			emission emissive emitter))) and (445/\$.ccls. 313/\$.ccls.		
5209814.pn, 5260163.pn, 5275699.pn, 5306756.pn, US-PGPUB			430/\$.ccls.)		
4 \$209814 pn. \$2056163 pn. \$2075699 pn. \$306756 pn. USPAT; Cold/10/08 14:16 USPAT;	-	1	5032216.pn.	USPAT;	2004/10/08 14:15
455 ((difus\$3)atem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 7 ((difus\$3)atem\$3 (dif(us\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) and 216/\$.cds. USPAT; US-PGPUB emission emissive emitter)) US-PGPUB emission emissive emitter)] US-PGPUB emission emiss				US-PGPUB	
455 ((diffus\$3patem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3) and ((electron field) near3 (source emitting emission emissive emitter))	-	4	5209814.pn. 5260163.pn. 5275689.pn. 5306756.pn.	USPAT;	2004/10/08 14:16
dielectric isolats3)) and ((electron field) near3 (source emitting emission emissive emitter)) 7 ((diffus\$3patem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) and 216/\$.ccis. 1658 ((diffus\$3patem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) and 524/\$.ccis. 1658 ((diffus\$3patem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 1658 ((diffus\$3patem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 1759 ((diffus\$pattem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 1870 ((diffus\$pattem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 1870 ((diffus\$pattem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) 1871 ((diffus\$pattem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) emission emissive emitter))) 1872 ((diffus\$pattem\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) emission emissive emitter))) 1873 (dielectric isolat\$3)) and (electrode cathode) emission emissive emitter))) 1874 ((diffus\$pattem\$4 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) emission emissive emitter))) 1875 ((diffus\$pattem\$4 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) emission emissive emitter)) and (diffus\$3 with pattern\$3)) emission em		1		US-PGPUB	
emission emissive emitteri) 7 ((diffus\$3)aten#3 (diffus\$3) and (((electron field) near3 (source emitting emission emissive emitteri)) and 25(4)s.cds. USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitteri)) and 25(4)s.cds. USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitteri)) and 25(4)s.cds. USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitteri)) and 25(4)s.cds. USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT; US-PGPUB dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) USPAT;	-	455	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3	USPAT;	2004/10/08 14:36
7 ((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) and 216/\$-c.ds. ((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter))) and 524/\$-c.ds. USPAT; USP-RGPUB emission emissive emitter)) and 524/\$-c.ds. USPAT; USP-RGPUB emission emissive emitter)) and (524/\$-c.ds. USPAT; USP-RGPUB emission emissive emitter)) (diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter)) (diffus\$patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter)) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter)) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter)) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (electrode cathode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (electrode cathode) (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 (electric isolat\$3)) and (electrode cathode)			dielectric isolat\$3)) and (((electron field) near3 (source emitting	US-PGPUB	
Delicetric isolats Delicetron field Dear3 (source emitting emission emissive emittery)) and 216/5 ccls. Delicetron field Dear3 (source emitting emission emissive emittery)) and 216/5 ccls. Delicetron field Dear3 (source emitting emission emissive emittery)) and 524/5 ccls. Delicetric isolats Delicetron field Dear3 (source emitting emission emissive emittery)) and 524/5 ccls. Delicetric isolats Delicetr			emission emissive emitter)))		
emission emission emission patterns3) same (insulat\$3 dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter))) and \$24/\$.ccis.	-	7		USPAT;	2004/10/08 14:43
1618 (Idiffus\$apterm\$3 (diffus\$3 with patterm\$3)) same (insulat\$3 dielectric isolat\$3)) and ((electron field) near3 (source emitting emission emissive emitter)) and 524/\$.ccis. (Idifus\$apterm\$3 (diffus\$apterm\$3) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) and (430/\$.ccis.		İ		US-PGPUB	
dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter)) and \$24/\$.c.ds.					
emission emissive emittery) and 524/s.ccls. 1658 (diffus\$3)atem\$ (diffus\$4) with pattern\$3) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) and (430/\$.ccls. 19-PGPUB 445/\$.ccls. 313/\$.ccls. 438/\$.ccls. 216/\$.ccls. 19-PGPUB 445/\$.ccls. 313/\$.ccls. 438/\$.ccls. 313/\$.ccls. 438/\$.ccls. 313/\$.ccls. 438/\$.ccls. 313/\$.ccls. 445/\$.ccls. 313/\$	-	0			2004/10/08 14:42
1658 ((diffus\$alpatern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) and (430/\$.ccls. US-PAT; US-PGPUB dielectric isolat\$3)) and ((insulat\$3 dielectric isolat\$3)) and ((insulat\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and				US-PGPUB	
dielectric isolat\$3)) and (electrode cathode) and (430/\$.cds. US-PGPUB 45/\$.cds. 31/\$.cds. 31/\$.cds. 31/\$.cds. 31/\$.cds. US-PGPUB 45/\$.cds. 31/\$.cds. 31/\$.cds. 31/\$.cds. 31/\$.cds. US-PGPUB emission emissive emitter)) 455 ((diffus\$3pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 US-PGPUB emission emissive emitter)) 455 ((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 US-PGPUB emission emissive emitter)) 455 (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 US-PGPUB emission emissive emitter)) 456 (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 US-PGPUB emission emissive emitter)) 476 (diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 US-PGPUB EPO; JPO; JPO; JPO; JPO; JPO; JPO; JPO; J					
445/\$.ccis. 313/\$.ccis. 438/\$.ccis. 216/\$.ccis.) ((diffus\$apatems*) diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) 455 (diffus\$apatems*) diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emis	-	1658		USPAT;	2004/10/08 14:43
455 ((diffus\$a)patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3) and (((electron field) near3 (source emitting emission emissive emitter))				US-PGPUB	
dielectric isolats33) and ((clectron field) near3 (source emitting emission emissi					
emission emissive emitteri)) - 455 ((diffus\$apattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitteri)) - 455 ((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emi	-	455		USPAT;	2004/10/08 14:44
455				US-PGPUB	
dielectric (solat\$3)) and (((electron field) near3 (source emitting emission emissio					
## ## ## ## ## ## ## ## ## ## ## ## ##	-	455		USPAT;	2004/10/08 14:44
455				US-PGPUB	
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22 ((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 EPO; JPO; DERWENT			dielectric isolat\$3)) and (((electron field) near3 (source emitting	DERWENT	
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emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.) (pattern\$3 with (thick near3 (dielectric insulat\$3 isolat\$3))) and (USPAT; US-PGPUB emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.) ((thick near3 (dielectric insulat\$3 isolat\$3))) and (cathode electrode) and (((electron field) near3 (emitting emission emissive electrode) and ((electron field) near3 (emitting emission emissive electrode) and (electron field) near3 (emitting emission emissive electrode) electrode) and (electron field) near3 (emitting emission emissive electrode) electrode) electrode) electrode) electrode) electrode electrode) electrode electrode) electrode electrode) electrode electrode electrode electrode electrode) electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode electrode		' '			2007/10/00 10:03
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- 372 ((thick near3 (dielectric insulat\$3 isolat\$3))) and (cathode uSPAT; electrode) and (((electron field) near3 (emitting emission emissive uS-PGPUB] !		03 FGF06	
electrode) and (((electron field) near3 (emitting emission emissive US-PGPUB	-	372		USPAT.	2004/10/08 16:12
emitter))) and (313/\$ cole 445/\$ cole)			electrode) and (((electron field) near3 (emitting emission emission		200 1/ 10/00 10.13
	_		emitter))) and (313/\$.ccls. 445/\$.ccls.)	35 . 3. 35	

-	66	(((thick near3 (dielectric insulat\$3 isolat\$3))) same (conventional	USPAT;	2004/10/08 16:27
	į	known)) and (cathode electrode) and (((electron field) near3	US-PGPUB	
		(emitting emission emissive emitter))) and (313/\$.ccls.		
		445/\$.ccls.)		
-	0	(thick\$dielectric same (conventional known)) and (cathode	USPAT;	2004/10/08 16:28
		electrode) and (((electron field) near3 (emitting emission emissive	US-PGPUB	
		emitter))) and (313/\$.ccls. 445/\$.ccls.)		
-	0	(thick\$dielectric) and (cathode electrode) and (((electron field)	USPAT;	2004/10/16 16:00
		near3 (emitting emission emissive emitter)))	US-PGPUB	
-	0	((and) and (and) and (((and and)	EPO; JPO;	2004/10/08 16:28
		near3 (emitting emission emissive emitter)))	DERWENT	
-	9	(thick near3 dielectric) and (cathode electrode) and (((electron	EPO; JPO;	2004/10/08 16:31
		field) near3 (emitting emission emissive emitter)))	DERWENT	
-	72	((thick near3 dielectric) same pattern\$3) and (cathode electrode)	USPAT;	2004/10/08 16:32
		and (((electron field) near3 (emitting emission emissive emitter)))	US-PGPUB	